

<b>Notice of References Cited</b>	Application/Control No. 10/064,452	Applicant(s)/Patent Under Reexamination LIAW ET AL.	
	Examiner Alonzo Chambliss	Art Unit 2827	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2004/0004296	01-2004	Cheng et al.	257/786
*	C	US-6,638,793	10-2003	Chen, Chung-Hui	438/123
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	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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